



DRJ

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yoichiro NUMASAWA et al.

Serial No. 10/645,908

Filed August 22, 2003

METHOD FOR FORMING AN OXYGEN- OR
NITROGEN-TERMINATED SILICON
NANOCRYSTALLINE STRUCTURE AND AN
OXYGEN- OR NITROGEN-TERMINATED
SILICON NANOCRYSTALLINE
STRUCTURE FORMED BY THE METHOD

: Confirmation No. 8539

: Attorney Docket No. 2003_1164A

: Group Art Unit 2891

: Examiner Asok K. Sarkar

: Mail Stop Amendment

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached hereto is a check in the amount of \$1,020.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time \$1,020.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

Yoichiro NUMASAWA et al.

For:

Michael R. Davis

Michael R. Davis

Registration No. 25,134

Attorney for Applicants

By:

Amy E. Schmid

Registration No. 55,965

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July 16, 2007

[Check No. 81292]
2003_1164A



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FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of January 16, 2007.

The fee of \$1,020.00 is
 submitted herewith.
 to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
 Small entity status of this application is established by a Small Entity Status Assertion which
 is enclosed.
 has been previously submitted.

Respectfully submitted,

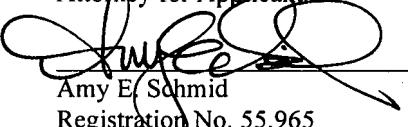
Yoichiro NUMASAWA et al.

For:



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